



Smagk

AF/2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tyler A. Lowrey

Serial No.: 09/944,478

Filed: August 31, 2001

For: Elevated Pore Phase-  
Change Memory

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Art Unit: 2814

Examiner: Tuan N. Quach

Docket: ITO.0506US  
P12499

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Please  
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3/25/04

**REPLY TO FINAL REJECTION**

Sir:

In response to the final rejection mailed February 12, 2004, reconsideration is requested  
in view of the following remarks.

Date of Deposit: March 2, 2004

I hereby certify under 37 CFR 1.8(a) that this correspondence is  
being deposited with the United States Postal Service as first class  
mail with sufficient postage on the date indicated above and is  
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Alexandria, VA 22313-1450.

Cynthia L. Hayden  
Cynthia L. Hayden